

Title (en)

Terminal protection cover and production mehtod for terminal device

Title (de)

Endgerätschutzabdeckung und Verfahren zur Herstellung des Endgeräts

Title (fr)

Couvercle de protection de terminal et procédé de production pour dispositif de terminal

Publication

EP 2498342 A2 20120912 (EN)

Application

EP 12001354 A 20120229

Priority

JP 2011054303 A 20110311

Abstract (en)

An object of the present invention is to provide a terminal protection cover with good space efficiency. A terminal protection cover 10 is provided with a main body 20 which includes an accommodation recess 21 capable of accommodating a terminal fitting 50 and a lid portion 60 which is coupled to one side wall 23A of the main body 20 via a hinge and rotatable to a closed position and an open position about the hinge. The main body 20 is bent in conformity with the shape of the terminal fitting 50 and includes a first main body 25 arranged at one side of a bent portion 24 and a second main body 26 arranged at the other side. The lid portion 60 includes a first lid portion 61 coupled to the first main body 25 and a second lid portion 61 coupled to the second main body 26. The first and second lid portions 61, 62 are rotatable in directions crossing each other.

IPC 8 full level

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CPC (source: EP)

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Citation (applicant)

JP 2009230993 A 20091008 - SUMITOMO WIRING SYSTEMS

Cited by

CN111613911A; CN111613910A; US11170916B2

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